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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Kurita, et al.
Serial No.: 09/464,362
Filed: December 15, 1999
For: DUAL SUBSTRATE LOADLOCK
PROCESS EQUIPMENT

Examiner: MacArthur, S.

Art Unit: 1763

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Assistant Commissioner for Patents
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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Dear Sirs:

In accordance with 37 CFR 1.56, 1.97, and 1.98, enclosed please find Form PTO-1449 listing the attached references which might be deemed material to the examination of the above-identified application. The information disclosure statement submitted herewith is being filed before the mailing date of a first Office Action after filing of a Request for Continued Examination under 1.114. It is believed that no fee is due. Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-0585. A duplicate of this letter is enclosed.

Respectfully submitted,

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April 15, 2002
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